

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryouichi INANAMI et al.

Serial No.: Not Yet Assigned

Filed: August 19, 2003

For: METHOD FOR CREATING CHARGED-  
PARTICLE-BEAM EXPOSURE DATA, METHOD  
FOR MANUFACTURING SEMICONDUCTOR  
DEVICE, AND PROGRAM

Group Art Unit: Not Yet Assigned

Examiner: Not Yet Assigned

MAIL STOP PATENT APPLICATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form. This Information Disclosure Statement is being filed with the above-referenced application.

The following are listed on the accompanying PTO-1449 and are in a non-English language:

1. Japanese Patent Publication No. 10-303126 – discloses the move courses of a stage.

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2. Japanese Patent Publication No. 2002-151383 – discloses apparatus and method for drawing patterns using an electron beam.

An English-language abstract of each document is enclosed.

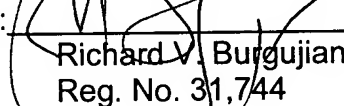
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: August 19, 2003

By:   
Richard V. Burgujian  
Reg. No. 31,744

Enclosures  
RVB/FPD/sci

# **INFORMATION DISCLOSURE CITATION**

Atty. Docket No. <b>04329.3115</b>	Serial No. <b>Not Yet Assigned</b>
Applicants <b>Ryouichi INANAMI et al.</b>	
Filing Date <b>August 19, 2003</b>	Group: <b>Not Yet Assigned</b>

## **U.S. PATENT DOCUMENTS**

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

## **FOREIGN PATENT DOCUMENTS**

Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
2002-151383	05/24/02	JAPAN			ABSTRACT
10-303126	11/13/98	JAPAN			ABSTRACT

## **OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

INANAMI, R. et al., "Charged Particle Beam Exposure Method And Method For Producing Charged Particle Beam Exposure Data", U.S. Application No. 10/255,830, filed September 27, 2002.
INANAMI, R. et al., "Exposure Pattern Data Generation Apparatus Associated With Standard Cell Library And Charged Beam Exposure", U.S. Application No. 09/817,270, filed March 27, 2001.

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce